

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:    **LEON MARTIN LEVASIER**  
                                 **ARIE JEFFREY DEN BOEF**  
                                 **INGO DIRNSTORFER**  
                                 **ANDRE BERNARDUS JEUNINK**  
                                 **STEFAN GEERTE KRUIJSWIJK**  
                                 **HENRICUS PETRUS MARIA PELLEMANS**  
                                 **IRWAN DANI SETIJA and**  
                                 **HOITE PEITER THEODOOR TOLSMA**

Application No.:	TO BE ASSIGNED	Confirmation No:
Filed:	December 16, 2003	Group No.:
		Examiner
For:	LITHOGRAPHIC APPARATUS WITH ALIGNMENT SUBSYSTEM, DEVICE MANUFACTURING METHOD, AND DEVICE MANUFACTURED THEREBY	

**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

**APPLICATION DATA SHEET**  
**37 C.F.R. § 1.76**

**BIBLIOGRAPHIC DATA**

**1. Applicant information**

First applicant: **LEON MARTIN LEVASIER**  
Citizenship: The Netherlands  
Residence: Stationsweg 8, NL-5321 NH Hedel, The Netherlands

Second applicant: **ARIE JEFFREY DEN BOEF**  
Citizenship: The Netherlands  
Residence: Het Fort 35, NL-5581 AB Waarle, The Netherlands

Third applicant: **INGO DIRNSTORFER**  
Citizenship: Austria  
Residence: Venbergsemolen 99, NL-5612 DX Eindhoven, The Netherlands

Fourth applicant: **ANDRE BERNARDUS JEUNINK**  
Citizenship: The Netherlands  
Residence: Burgemeester Aartslaan 39, NL-5571 TR Bergeyk, The Netherlands

Fifth applicant: **STEFAN GEERTE KRUIJSWIJK**  
Citizenship: The Netherlands  
Residence: Mathijssenlaan 2, NL-5644 JK Eindhoven, The Netherlands

Sixth applicant: **HENRICUS PETRUS MARIA PELLEMANS**  
Citizenship: The Netherlands  
Residence: De Pruikenmaker 20, NL-5506 CT Veldhoven, The Netherlands

Seventh applicant: **IRWAN DANI SETIJA**  
Citizenship: The Netherlands  
Residence: Joke Smitplein 29, NL-3581 PZ Utrecht, The Netherlands

Eighth applicant: **HOITE PIETER THEODOOR TOLSMA**  
Citizenship: The Netherlands  
Residence: Picardiehof 17, NL-5627 HL Eindhoven, The Netherlands

## **2. Correspondence information**

Correspondence for this application should be addressed as follows:

Customer No.: 00909

## **3. Application information**

Title of Invention: **LITHOGRAPHIC APPARATUS WITH ALIGNMENT SUBSYSTEM,  
DEVICE MANUFACTURING METHOD, AND DEVICE  
MANUFACTURED THEREBY**

Docket number assigned to this application: 081468-0307255

Total number of drawing sheets: 8

Type of application: Utility

Application is to be published. Suggested drawing figure for publication: **FIGURE 3**

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

## **4. Representative information**

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

## **5. Foreign priority information**

Foreign priority is claimed for this application as follows:

Country: EUROPE  
Application No.: 02080334.2  
Filing Date: December 16, 2002

Country: EUROPE  
Application No.: 03075423.9  
Filing Date: February 14, 2003

Country: EUROPE  
Application No.: 03076010.2  
Filing Date: April 4, 2003

**6. Assignee information**


The assignee(s) of this application is/are:

ASML NETHERLANDS B.V.  
De Run 1110, NL-5503 LA Veldhoven, THE NETHERLANDS  
Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST

Date: **December 16, 2003**

PILLSBURY WINTHROP LLP  
P.O. Box 10500  
McLean, VA 22102  
Tel. No.: (703) 905-2085

Customer No.: 00909

  
\_\_\_\_\_  
Signature of Practitioner  
Kerry T. Hartman  
Reg. No.: 41818